

Electronic Acknowledgement Receipt

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Application Number:	10611631
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Title of Invention:	SILICON WAFER BASED MACROSCOPIC MIRROR FOR WIDE ANGLE SCANNING APPLICATIONS
First Named Inventor:	Joseph T. Pesik
Customer Number:	24024
Filer:	Brian E. Kondas
Filer Authorized By:	
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1		mbc2691.pdf	196962	yes	6

	Multipart Description		
	Doc Desc	Start	End
	Transmittal letter	1	1
	Letter to Official Draftsman Filed P/E	2	2
	Drawings	3	6
Warnings:			
Information:			
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